

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
SHUJI AOKI ET AL.) : Examiner: K.J. Ramsey
Application No.: Division) : Group Art Unit: 2879
of U.S. Patent Appln.)
No. 10/209,876)
Filed: Herewith)
For: METHOD AND APPARATUS FOR)
ADJUSTING CHARACTERISTICS :
OF ELECTRON SOURCE, AND)
METHOD FOR MANUFACTURING :
ELECTRON SOURCE) February 9, 2004

Mail Stop
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT
AND
INFORMATION DISCLOSURE STATEMENT

Sir:

Preliminary to examination, please amend the above-identified application,
filed herewith, as follows: